



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Mei, et al.

Serial No. 10/064,156

Filed: June 14, 2002

For: MODIFIED PHOTOLITHOGRAPHY  
MOVEMENT SYSTEM

§ Group Art Unit: 2125  
§ Examiner: Cabrera, Zoila E  
§ Attorney Docket No. 22397.324  
§  
§  
§

AMENDMENT

OK to be  
entered  
2/12/06  
Mail Stop AF  
Commissioner For Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed November 1, 2005, please amend the above-identified patent application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.